

Introduction to Clean Room and vacuum systems

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The Scale of Things – Nanometers and More

Things Natural

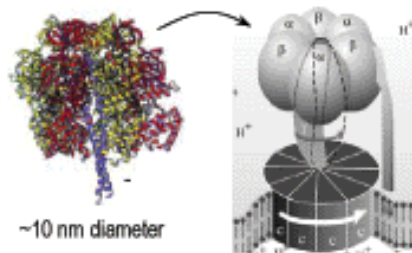


Dust mite
200 μm



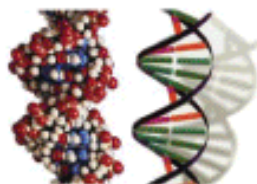
Human hair
~ 60-120 μm wide

Red blood cells
(~7-8 μm)



~10 nm diameter

ATP synthase



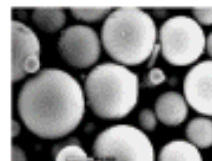
DNA
~2-1/2 nm diameter



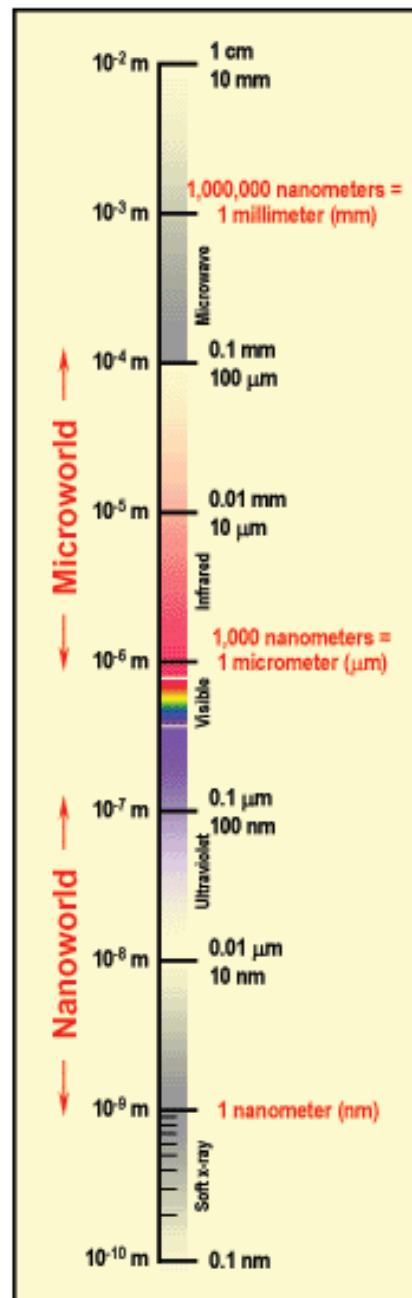
Atoms of silicon
spacing 0.078 nm



Ant
~ 5 mm



Fly ash
~ 10-20 μm



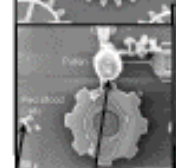
Things Manmade



Head of a pin
1-2 mm

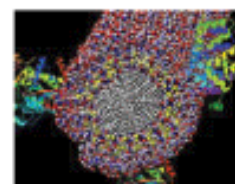
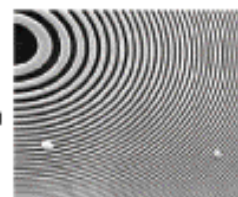


MicroElectroMechanical (MEMS) devices
10 -100 μm wide

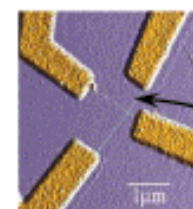


Pollen grain
Red blood cells

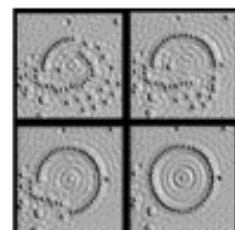
Zone plate x-ray "lens"
Outer ring spacing ~35 nm



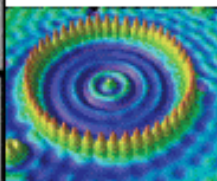
Self-assembled,
Nature-inspired structure
Many 10s of nm



Nanotube electrode



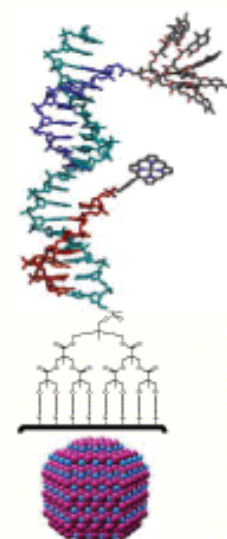
Quantum corral of 48 iron atoms on copper surface
positioned one at a time with an STM tip
Corral diameter 14 nm



Carbon buckyball
~1 nm diameter

Carbon nanotube
~1.3 nm diameter

The Challenge



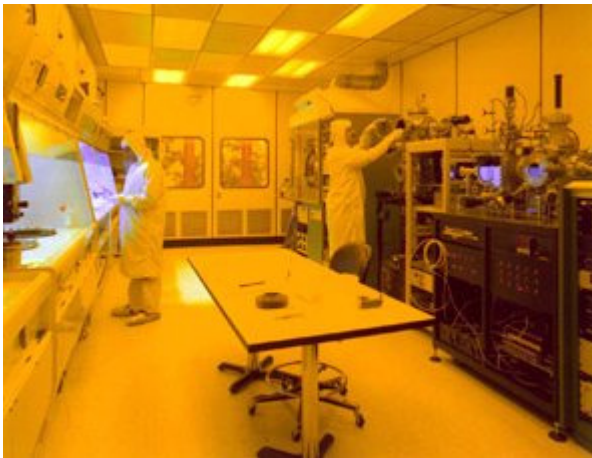
Fabricate and combine nanoscale building blocks to make useful devices, e.g., a photosynthetic reaction center with integral semiconductor storage.

Wafer processing - I

Clean room environment

Semiconductor clean room:

- controlled temperature (20°C), air pressure, humidity (30%)
- controlled airborne particulates
- controlled vibration
- controlled lighting



If you've never done it before, putting on a bunny suit can take 30 to 40 minutes.
The **Intel pros** can do it in five.

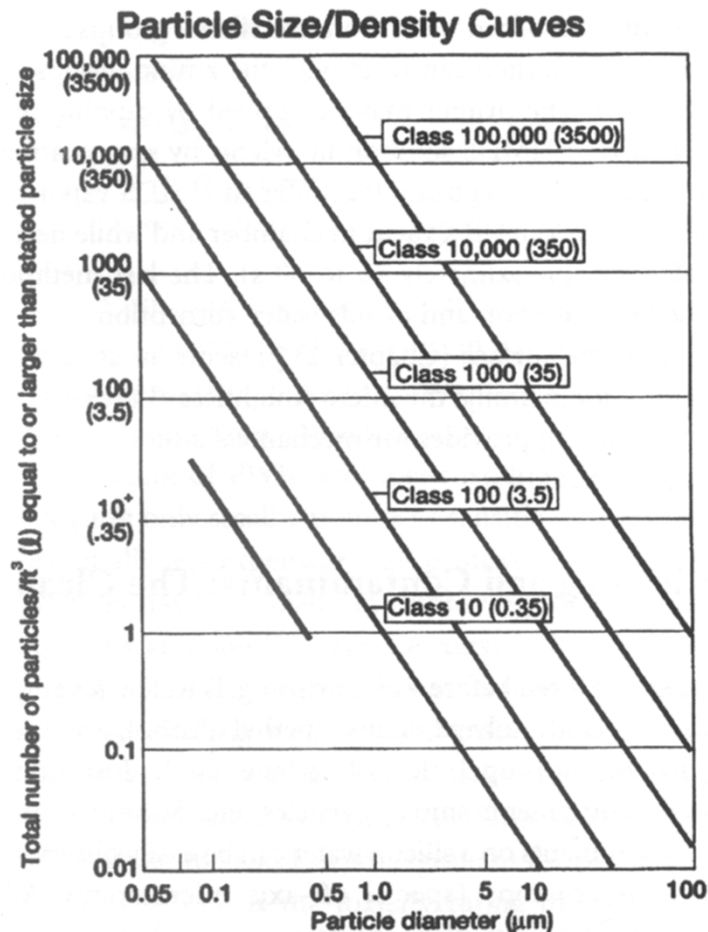


INESC:

250 m² Class 10 and 100 clean room
250 m² Class 10000 (grey area)

HEPA(High Efficiency Particulate Air Filter)

- for maintaining contamination control
- Filtering particles down to 0.3 microns



ISO 14644-1 cleanroom standards

Class	particles/m ³					
	0.1 µm	0.2 µm	0.3 µm	0.5 µm	1 µm	5 µm
ISO 1	10	2				
ISO 2	100	24	10	4		
ISO 3	1,000	237	102	35	8	
ISO 4	10,000	2,370	1,020	352	83	
ISO 5	100,000	23,700	10,200	3,520	832	29
ISO 6	1,000,000	237,000	102,000	35,200	8,320	293
ISO 7				352,000	83,200	2,930
ISO 8				3,520,000	832,000	29,300
ISO 9				35,200,000	8,320,000	293,000

Cleanroom class comparison

The following classes are mostly equivalent, although the testing standards differ

ISO 14644-1 FED STD 209E

ISO 3	1
ISO 4	10
ISO 5	100
ISO 6	1,000
ISO 7	10,000
ISO 8	100,000

INESC

Vacuum systems

Vacuum basics

- **What is a vacuum?**
 - ♦ Any gas at sub-atmospheric pressure
 - ♦ Vacuum is really the absence of gas
 - ♦ Vacuum is not absolute, but a continuous range of conditions
 - 15 orders of magnitude in common usage
- **Pressure is Force per Unit Area**
 - ♦ Pounds/sq. in
 - ♦ Newtons / sq.meter
 - ♦ Tons/ sq. angstrom
 - ♦ Atmospheric Pressure
 - 14.7 pounds/sq. in.
 - 10^5 Newtons/sq. meter
 - approx. ton/sq ft
 - approx. kg(force) / sq.cm.
- **SI UNITS:**
 - ♦ Pascal = 1 Newton/ sq. meter
 - ♦ 1 atm = 10^5 pascals
 - ♦ Non-Si Units: (common units)
 - ♦ Torr, millitorr
 - ♦ Bar, millibar
- **Torr is an archaic unit but widely used and widely understood**
 - ♦ Avoiding it is difficult

What is vacuum

Ideal gas law: $P V = N k T$

Pressure

Volume

molecules

$k = 1.38 \times 10^{-23}$ Joules/molecule/Kelvin
(Boltzmann's Constant)

Temperature

$(T \text{ const}) \Rightarrow P \sim N$

10^3 Torr

10^2 Torr

10^1 Torr

1 Torr

10^{-1} Torr

10^{-2} Torr

10^{-3} Torr

10^{-4} Torr

10^{-5} Torr

10^{-6} Torr

10^{-8} Torr

10^{-9} Torr

10^{-10} Torr

1 Atm = 760 Torr
= 1 bar

100 millitorr

10 millitorr

1 millitorr

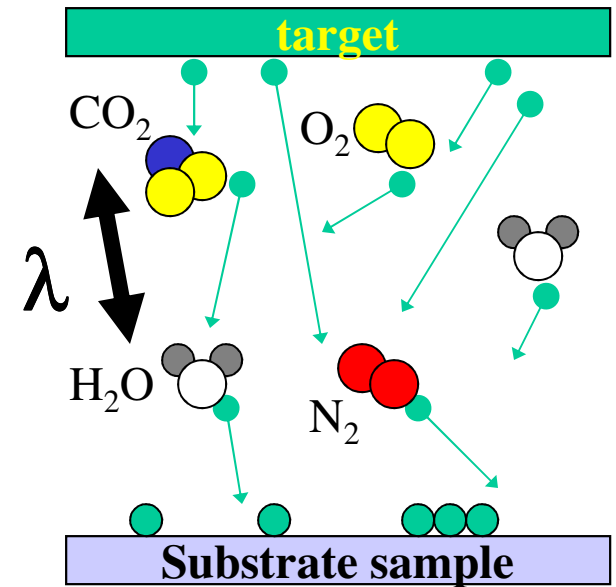
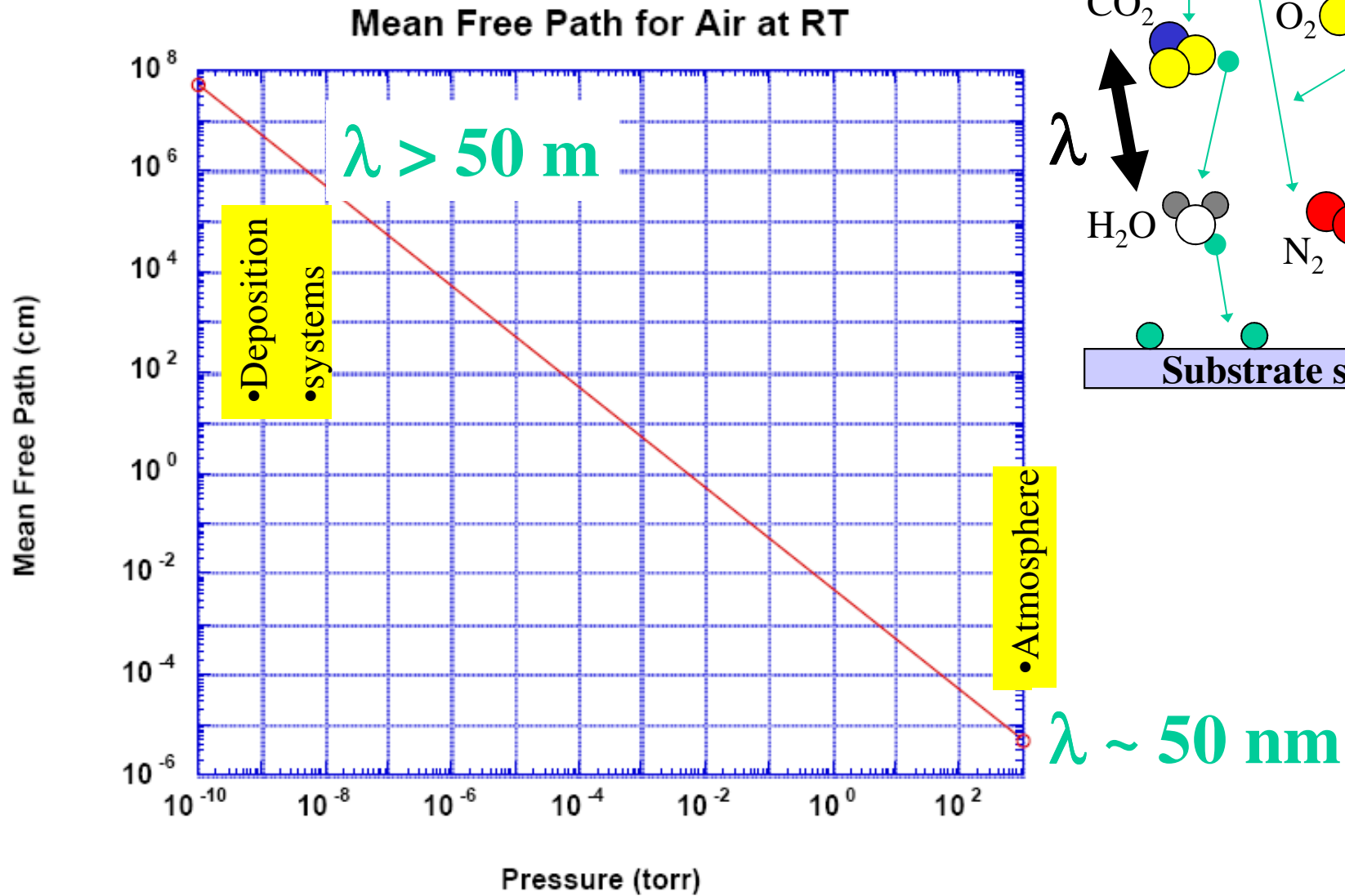
Sputtering
machines

- Mean free path (λ)**

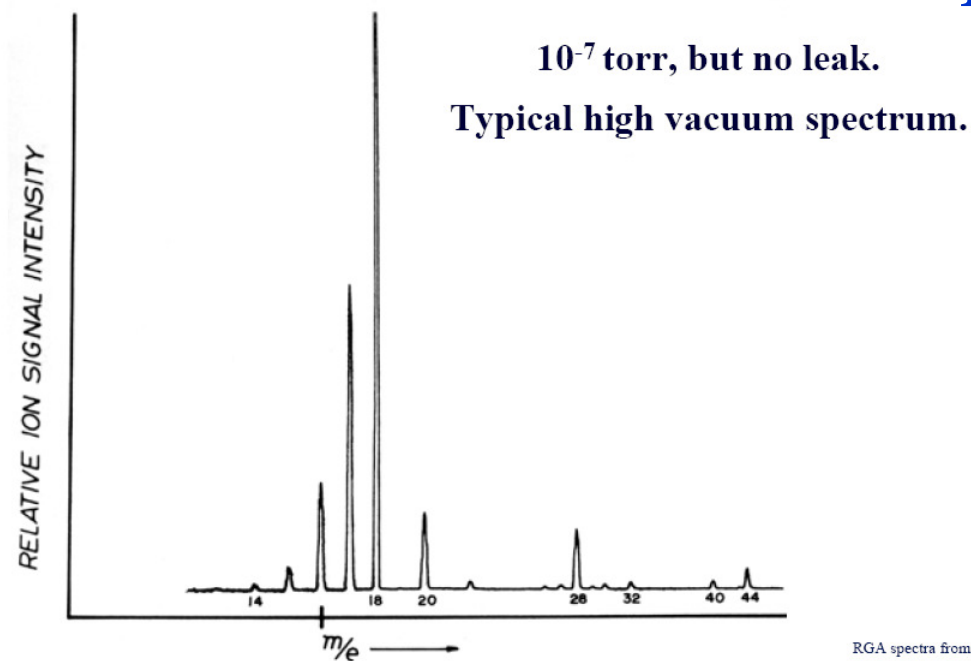
- How far does a molecule go before it strikes another?

- Impingement rate --- Surface Flux**

- How many molecules strike the surface in a given period of time?

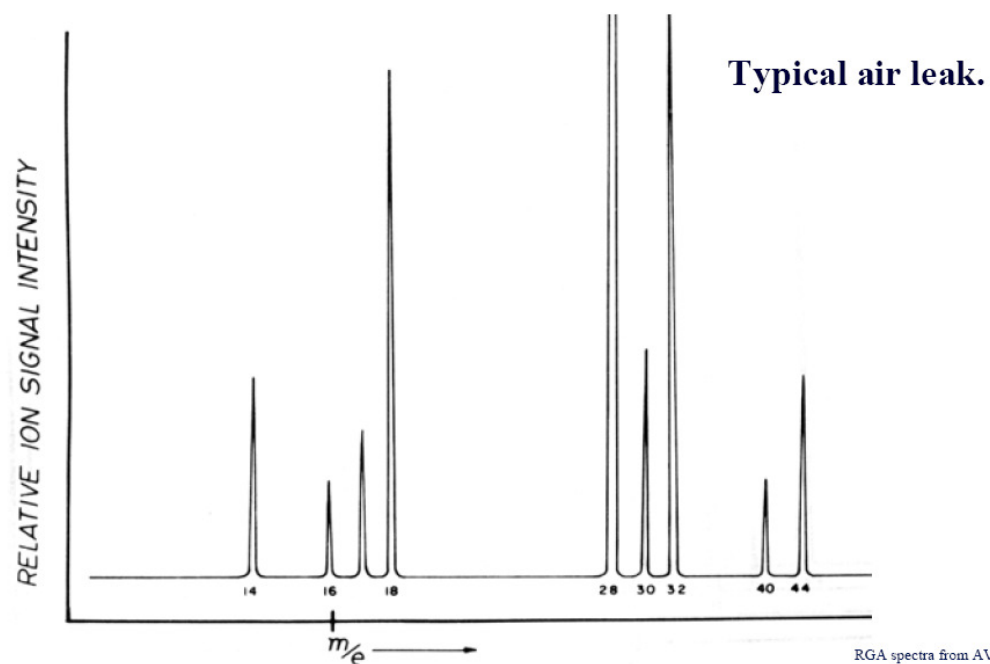


•Residual gas analyzer (RGA)



•RGA

•Vacuum chamber



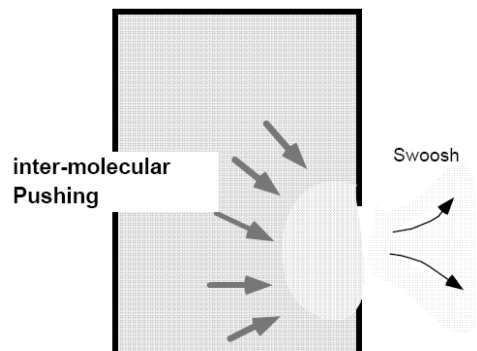
Mass	Species	Explanation
0		Zero Blast , unfiltered fragments
1	H	Cracking of hydrogen
2	H ₂	Dominant Species at UHV
4	He	Permeation through polymers or leak detection residue
16	O	Crcking of O2 or H2O. Electron Desorption from Surfaces
16	CH ₄	Methane produced in system by ion pumps
18	Water	Dominant Species except at UHV
19	F	ionic ghost, see below
20	Ne, Ar ++	Inert Gases not pumped well by ion pumps
28	N ₂	Air leak if accomanied by 14
28	CO	A major constituent at UHV. Desorption
35	Cl	Process gas or residue or ionic ghosts (see below)
37	Cl isotope	
40	Ar	Inert Gases not pumped well by ion pumps
>40		Generally hydrocarbon contamination
intervals of 14		CH ₂ groups cracked off long hydrocarbon chain
16,19,35,37		Residue of O,F,Cl desorbed from surfaces in RGA by electron bombardment. Artifacts.

- $MFP \ll "a"$

Fluid like

“crowded”

- Molecules interact with each other more than walls
 - Act as a “fluid”
 - Flow
 - Diffusion
 - Viscosity
 - Familiar region
 - Molecules act on each other
 - We can act on the gas “as a whole”
 - Essentially most of “rough” vacuum range
- Viscous Flow

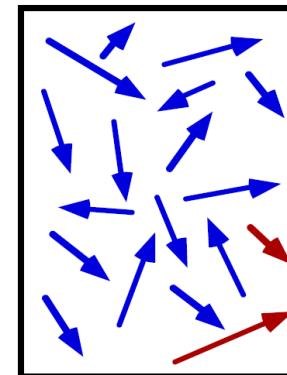


- $MFP \gg "a"$

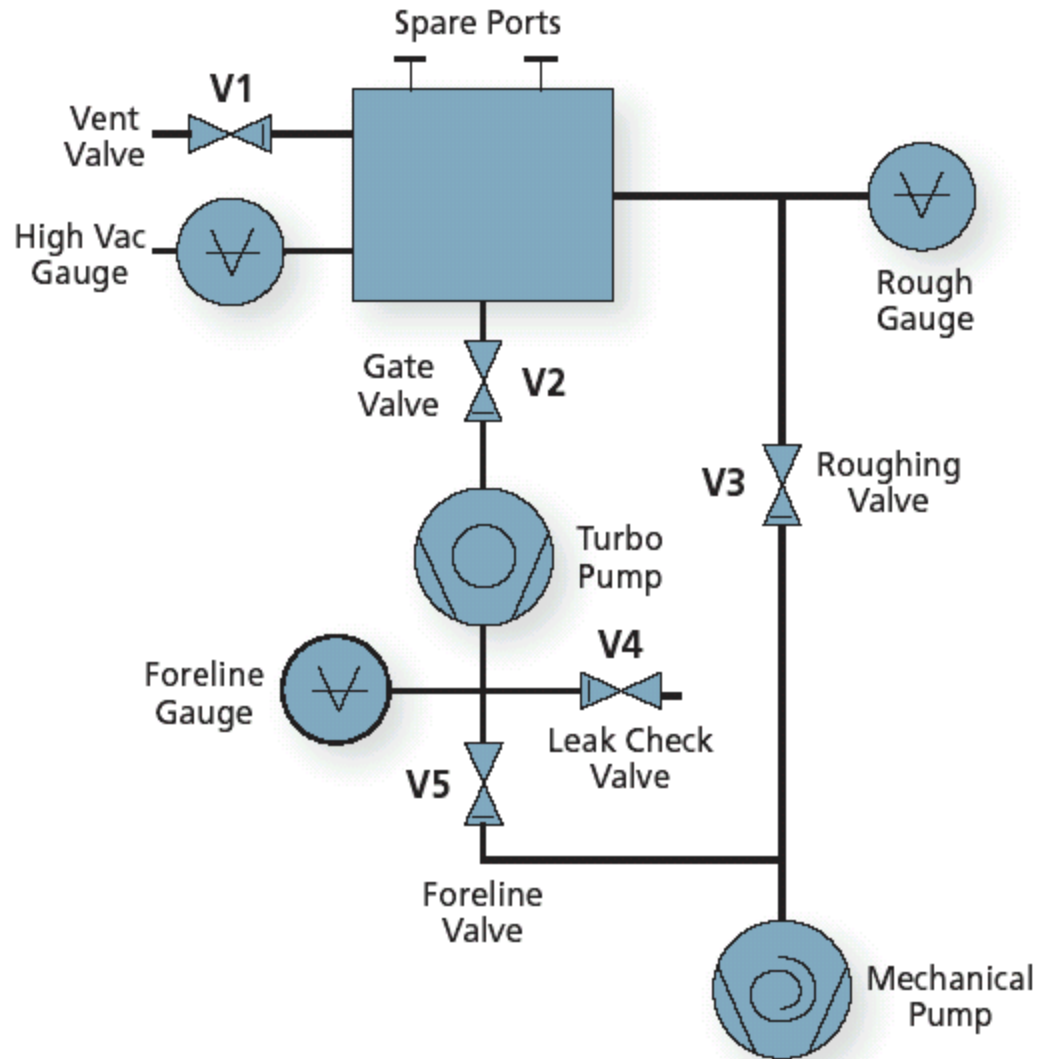
Molecule like

“sparse”/ “vacant”

- A “sparse” gas on the scale of the tube dimension
 - Molecules interact only with the walls
 - Every molecule to itself
 - No intermolecular forces or energy transfer
 - We can only act on ONE MOLECULE AT A TIME
 - A VERY UNFAMILIAR REGIME.
 - Most of mid, high and ultra high vacuum
- Free Molecular Flow



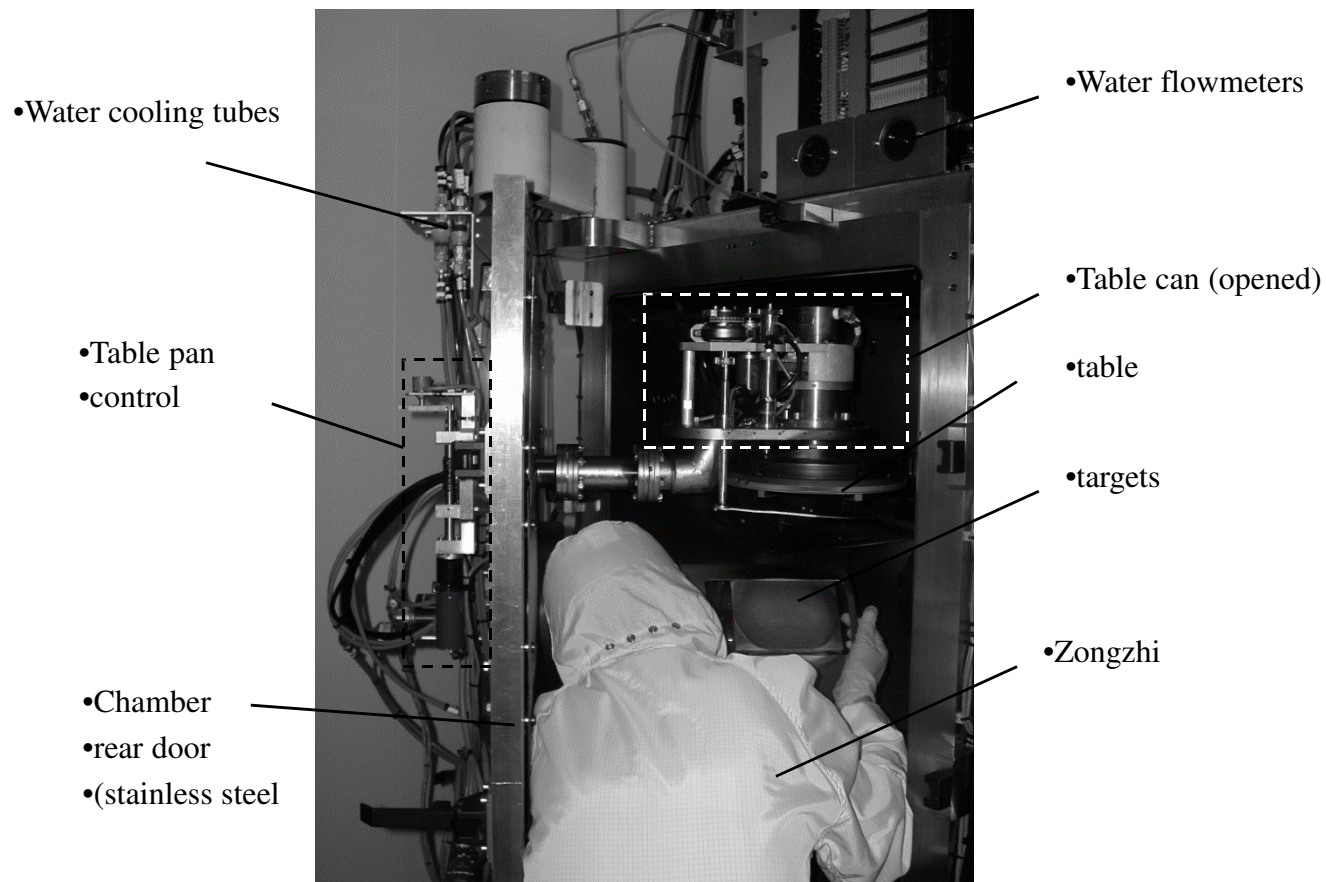
Vacuum systems



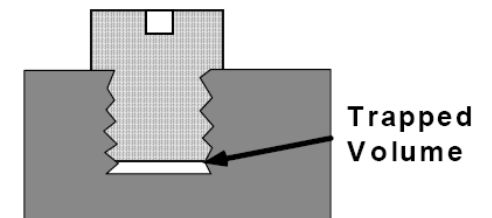
Vacuum chambers need to have several holes...

Problems:

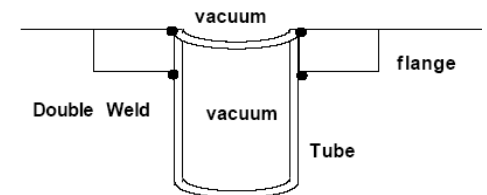
- Material degasing
- Water adsorbed



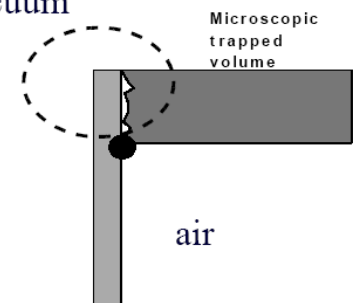
An un-vented screw

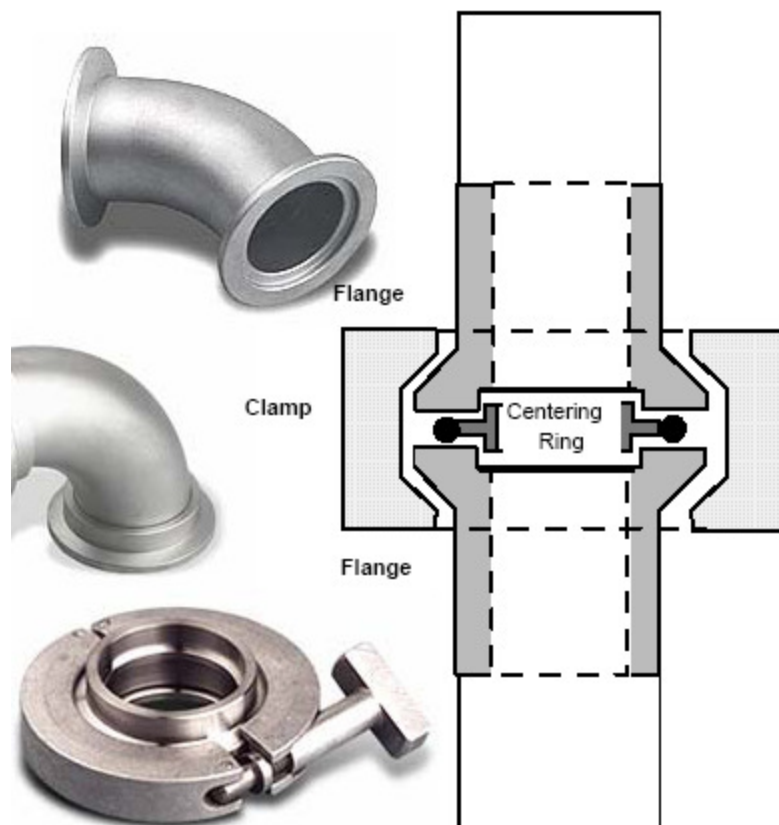


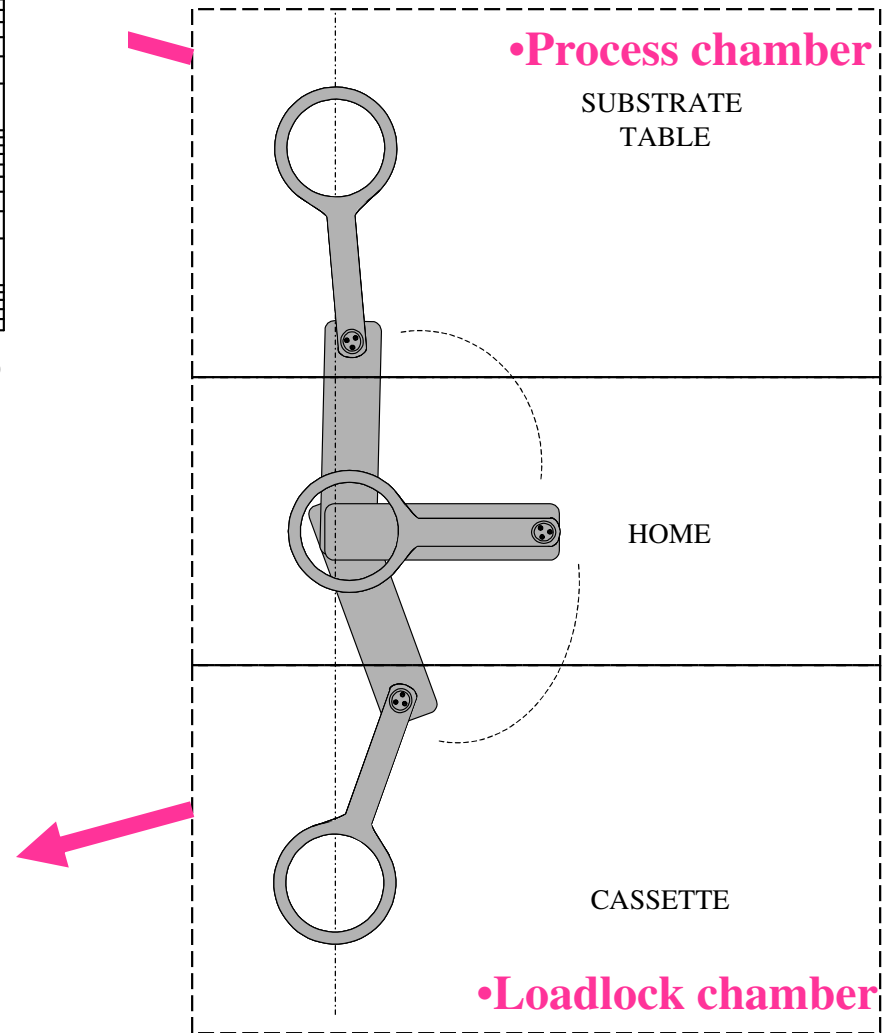
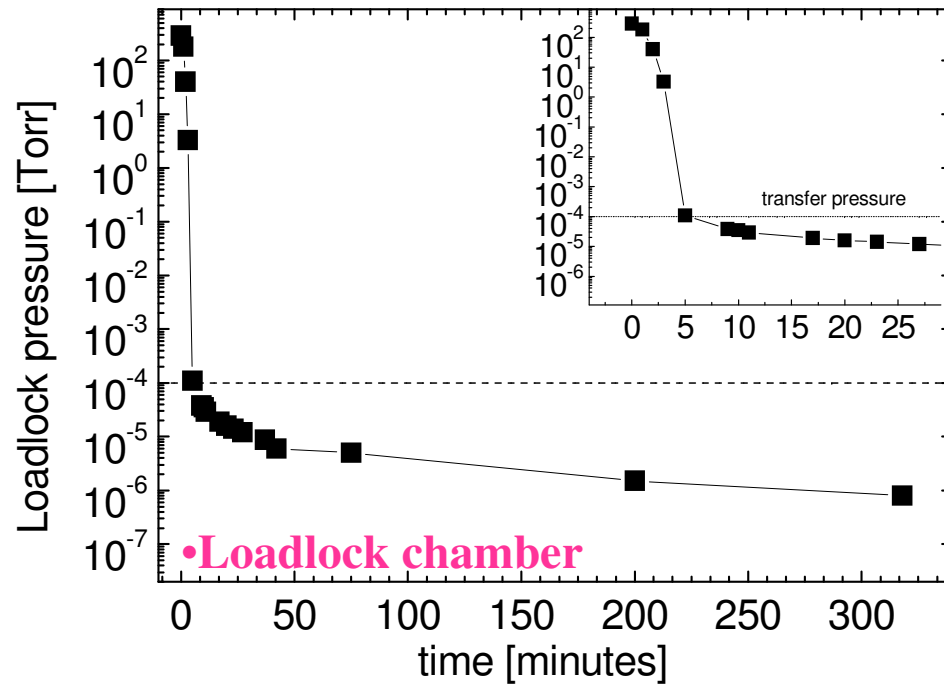
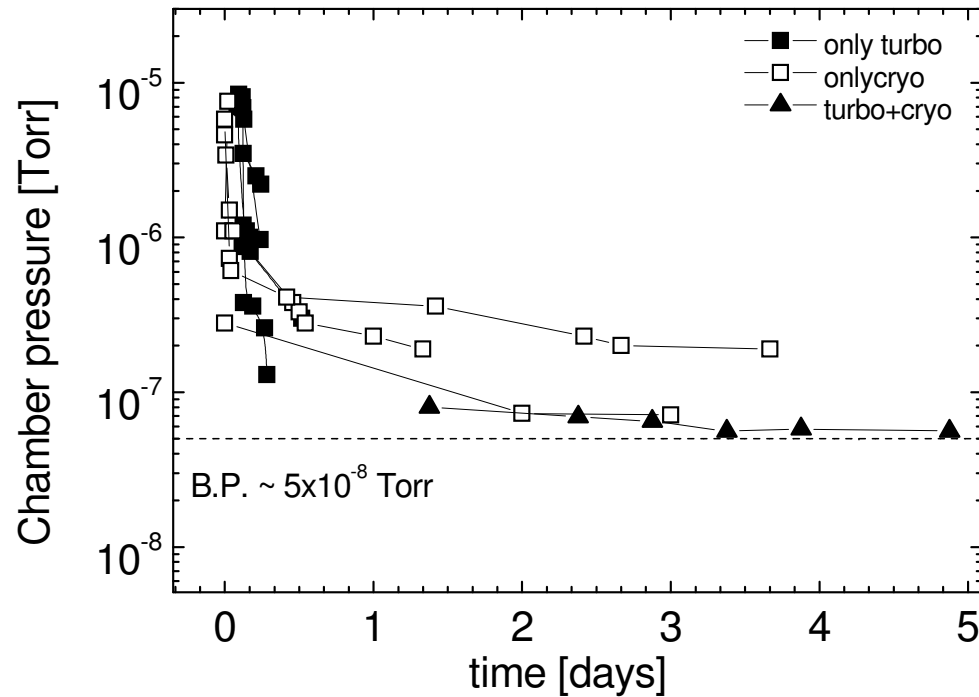
Vented screws??



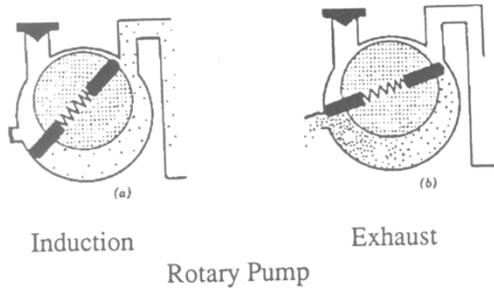
Vacuum





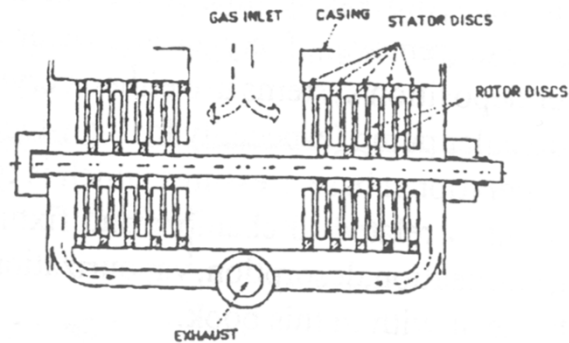


•Rotary pumps



- 1st stage pumps
- ultimate pressure $\sim 10^{-4}$ Torr
- Requires a purge vapor line

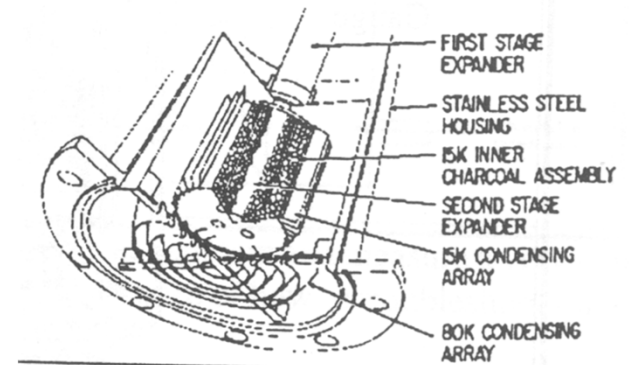
•Turbomolecular pumps



- Momentum transfer from the disks to the gas molecules.
- Separation rotor to disks \sim free mean path (molecular regime)

- 2nd stage pumps
- ultimate pressure $\sim 10^{-10}$ Torr
- requires a backing pump

•Cryogenic pumps



- 2nd stage pumps
- ultimate pressure $\sim 10^{-11}$ Torr

Rough vacuum pumps

- **Advantages:**

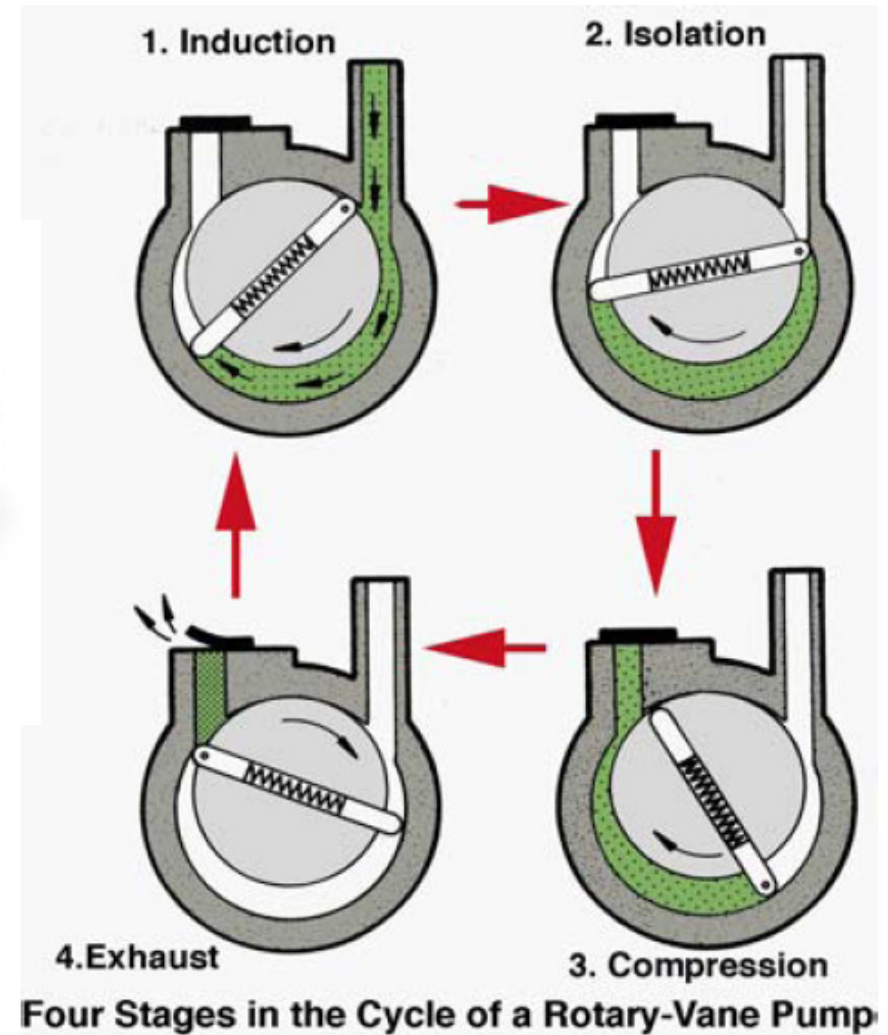
- Reliable
- Cheap
- Removes gases permanently

- **Rotary pumps**



- **Disadvantages:**

- Noisy
- Dirty
- Oily
- Big
- Heavy



Most “mechanical pumps” require a Pump Fluid

- **Functions:**

- Lubricant
- Sealant
- Heat Transfer/coolant
- Corrosion Protection



- Syntetic oils
- (Fomblin , 400€/l

- **Requisite Properties:**

- Chemically stable
- Thermally stable
- Appropriate lubricating ability
- Appropriate viscosity
- Low vapor pressure

• High vacuum pumps

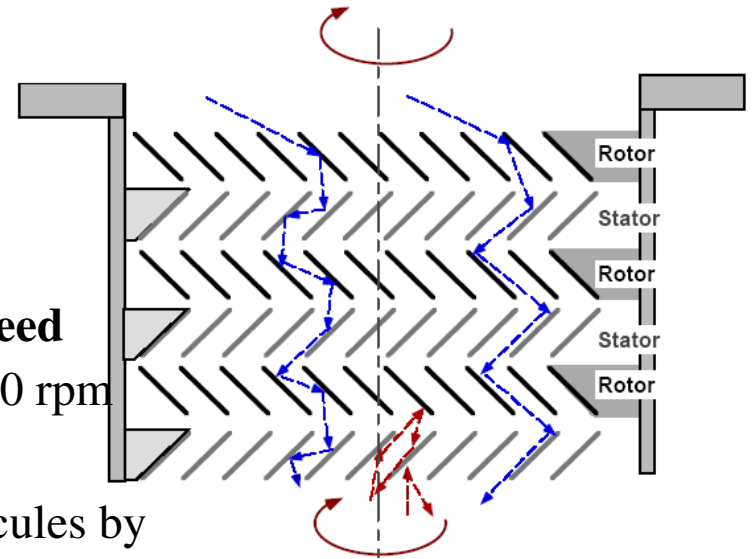


• Turbomolecular pumps

• Blade speed ~ molecular speed

• 40 000 – 80 000 rpm

- Multiple stages
- Transfer of momentum to molecules by collision with high speed turbine blades



• Pumping speed proportional to blade speed

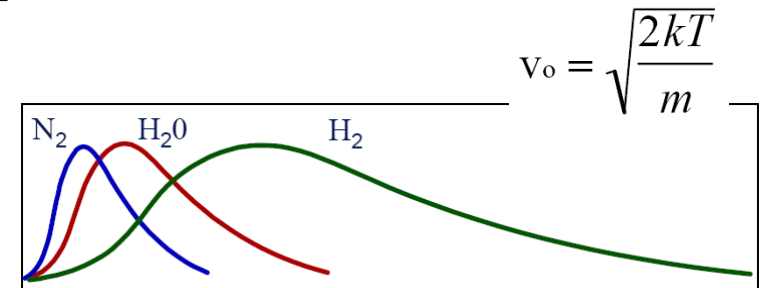
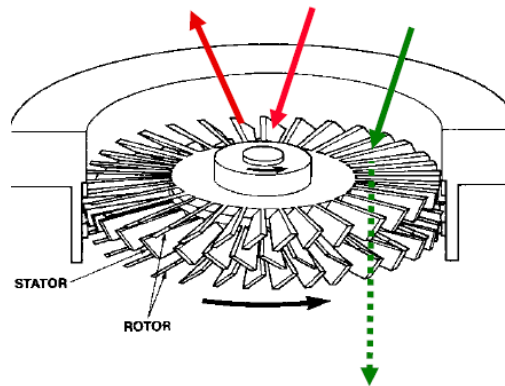
• Only the tips pump well

• Pumps very badly when not up to full speed

• Can take 15 minutes to get up to speed (big ones)

• Variety of sizes:

- 100 l/sec small and compact
- 2500 l/sec BIG and EXPENSIVE



• Can pump reactive gases

• Heavy gases are pumped better (slower)

• At ultimate pressures, the residual gas is 99% H₂

• Vibration

• Needs a backing pump

• Catastrophic failure (metal

•High vacuum pumps

•Cryogenic pumps

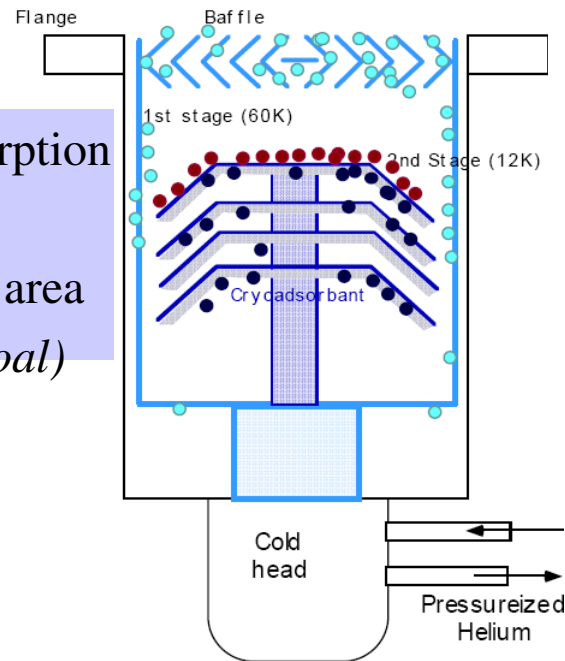
- Gas condensation + adsorption
- cold surface and/or large area
- (porous: activated charcoal)

• Advantages:

- Clean
- Fast at moderate cost
- Can be BIG
- HV and UHV compatible to 10^{-9} torr
- Almost Infinite Capacity (except He, H₂)

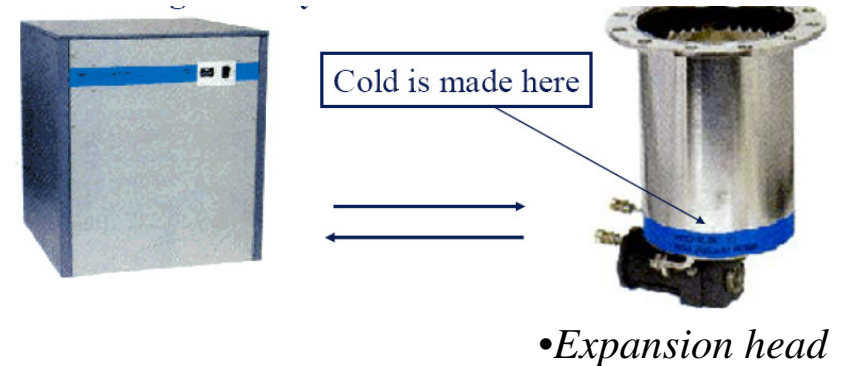
• Disadvantages:

- Store Large quantity of gas
- Toxics
- Reactives
- Vibration
- Heat Sensitivity
- **Not for reactive gases**



- Ultra-pure Helium working fluid
- External compressor

•Cryo Pump



Periodically saturates with adsorbed gases

- Saturate the pores so it wont pump He/H₂
- Physically obscure the entry way with “ice”
 - the frosty refrigerator problem

Capacity.

- Almost infinite for H₂O, N₂, O₂
- Limited for H₂, He
- Moderate for Ar

• Months between regenerations

Cryopumps are capture pumps.

Gases pumped are retained only while the pump is cold.

Gases stored may be toxic, flammable, or result in high pressures when the pump is warmed up.

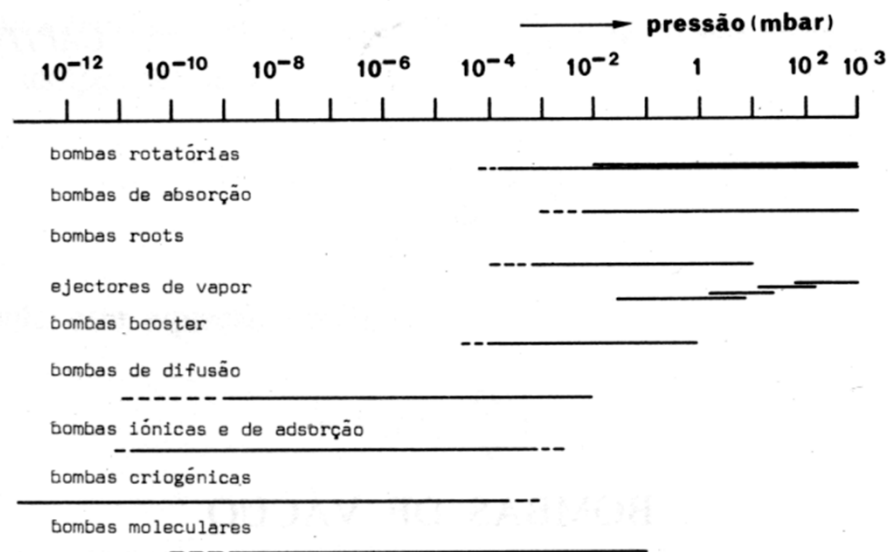


Fig. 3.1 — Zonas de pressão correspondentes às bombas indicadas

•Pirani

- Ultimate pressure
- detection $\sim 10^{-4}$ Torr

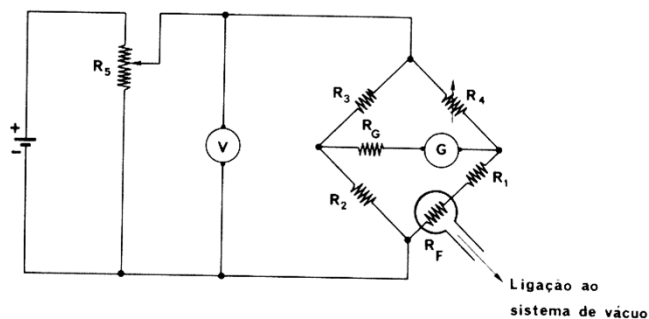


Fig. 4.7 — Circuito de medida para um Pirani

- Pressure increase \rightarrow lower filament temperature
- \rightarrow Lower resistance

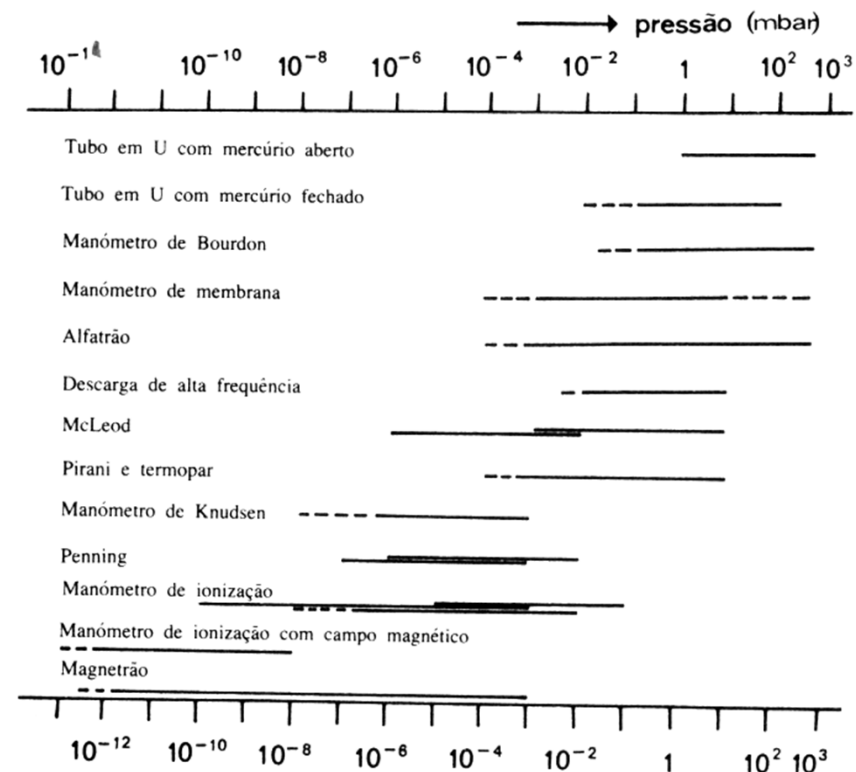


Fig. 4.15 — Zonas de trabalho de vários vacuômetros

•Penning

- Ultimate pressure
- detection $\sim 10^{-8}$ Torr

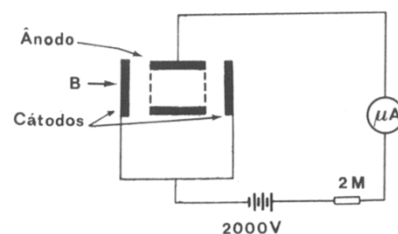


Fig. 4.13 — Manômetro de ionização de cátodo frio — Penning

A presença de um campo magnético faz aumentar o percurso dos electrões e portanto eleva a eficiência de ionização.

•Bayard-Alpert

- Ultimate pressure
- detection $\sim 10^{-11}$ Torr

